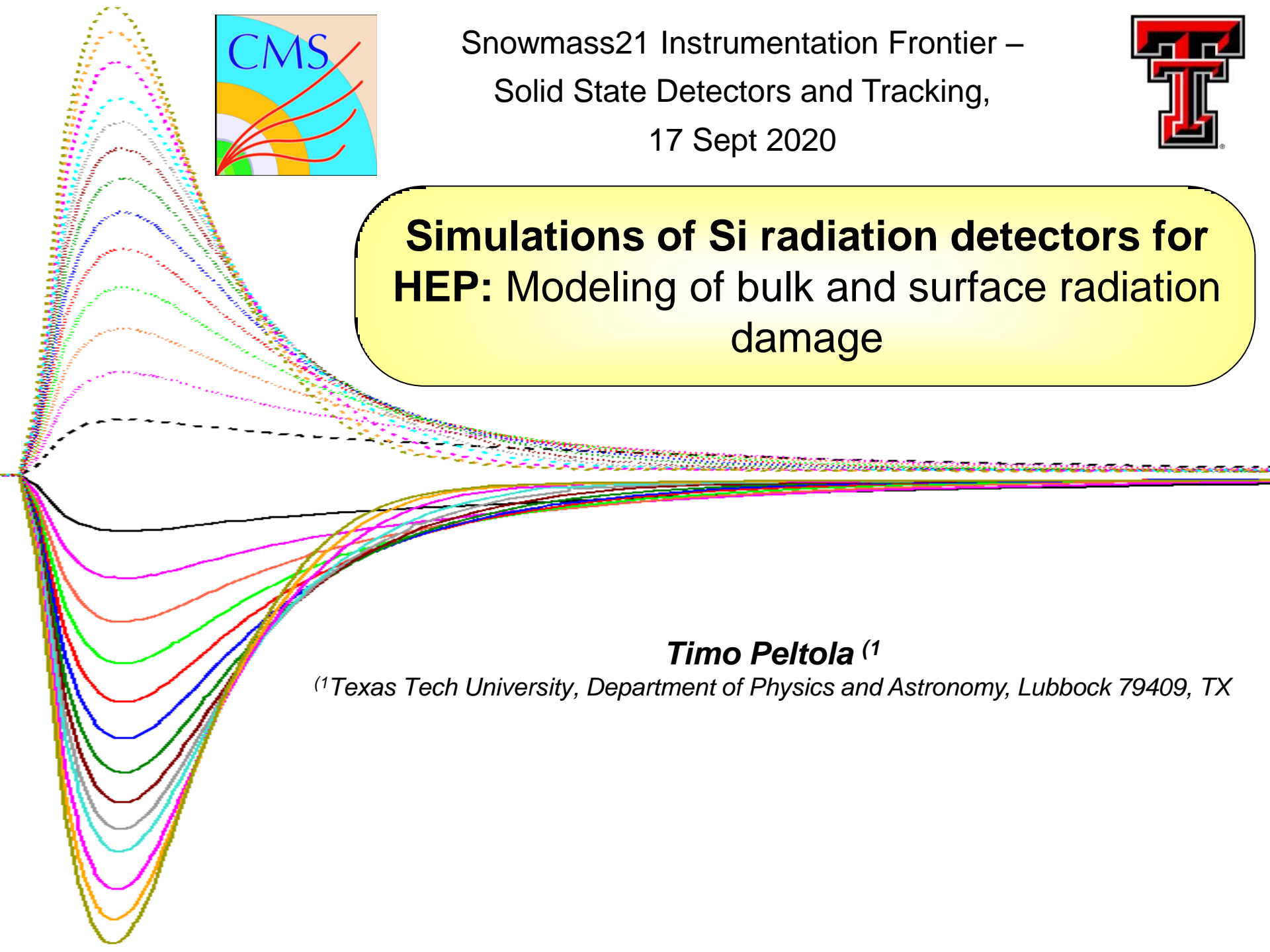




**Simulations of Si radiation detectors for  
HEP: Modeling of bulk and surface radiation  
damage**



***Timo Peltola*** <sup>(1)</sup>

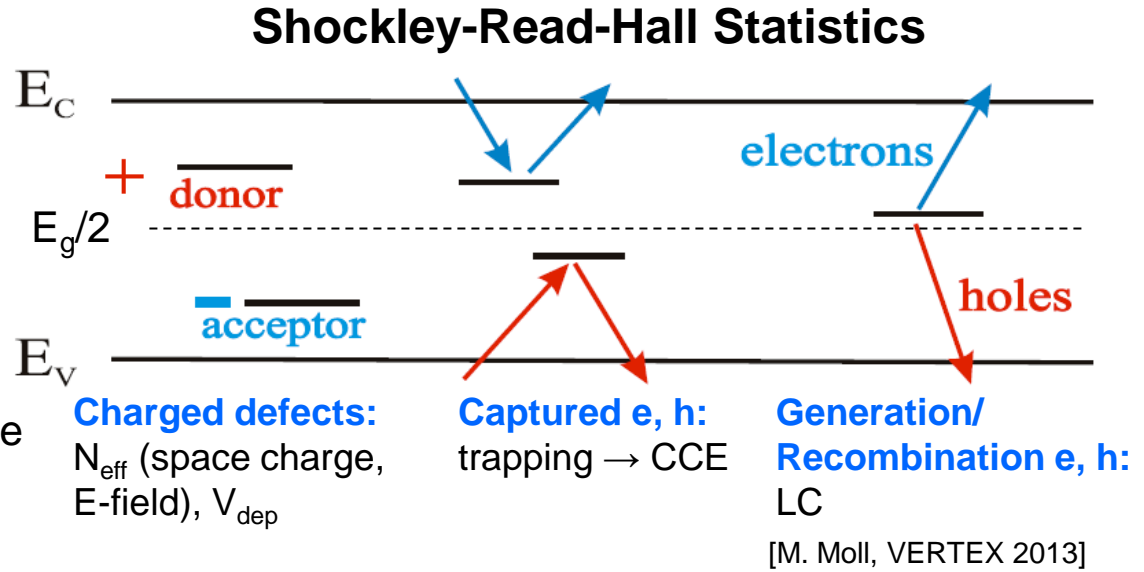
*(<sup>1</sup>Texas Tech University, Department of Physics and Astronomy, Lubbock 79409, TX*

# **Radiation induced defects in Si: Modeling**

# Radiation damage in Si: Defect Parameters

- ❑ Radiation ( $\Phi_{eq} > 1e13 \text{ cm}^{-2}$ ) causes damage to Si crystal structure ( $\Phi_{eq} = 1\text{-MeV } n_{eq}$ )
- ❑  $\Phi_{eq} > 1e14 \text{ cm}^{-2}$  lead to significant degradation of CCE due to charge carrier trapping

- ❑ **Bulk & surface damage affect detector performance:**
  - **Bulk:** Deep acceptor & donor type trap levels
  - **Surface:** Charge layer accumulated inside oxide



- ❑ 11 defect levels observed to influence irradiated Si detectors (backups 1-2)
- $\rightarrow$  Vast parameter space to model

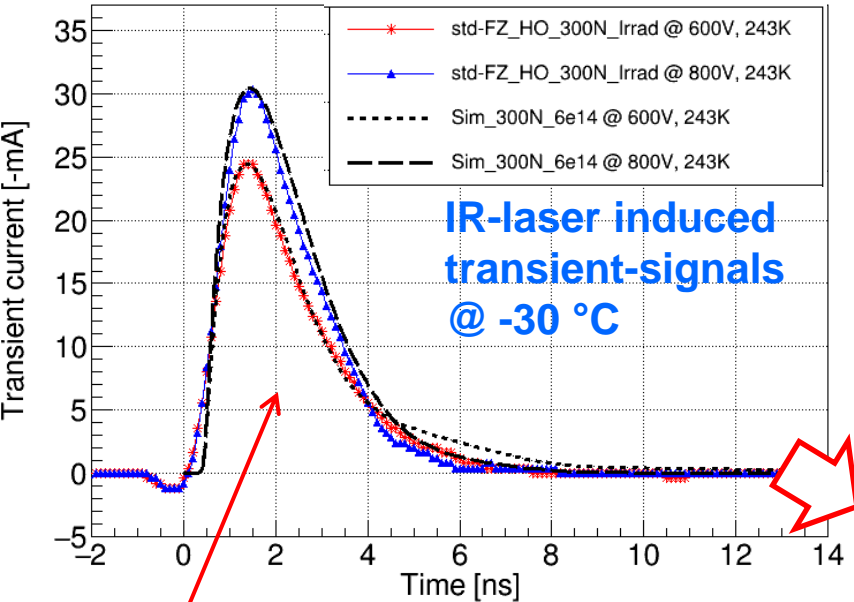
## Defect parameters

Defect type	$E_a$ [eV]	$\sigma_n$ [ $\text{cm}^2$ ]	$\sigma_p$ [ $\text{cm}^2$ ]	$N_t$ [ $\text{cm}^{-3}$ ]
Acceptor	$E_C - x_1$	$O(1e-14)$	$O(1e-14)$	$\eta_1 \cdot \Phi + c_1$
Donor	$E_V + x_2$	$O(1e-14)$	$O(1e-14)$	$\eta_2 \cdot \Phi + c_2$

Effective models needed for simulation

# Simulated defects I: bulk damage

# Transient currents & CCE: Measured vs simulated

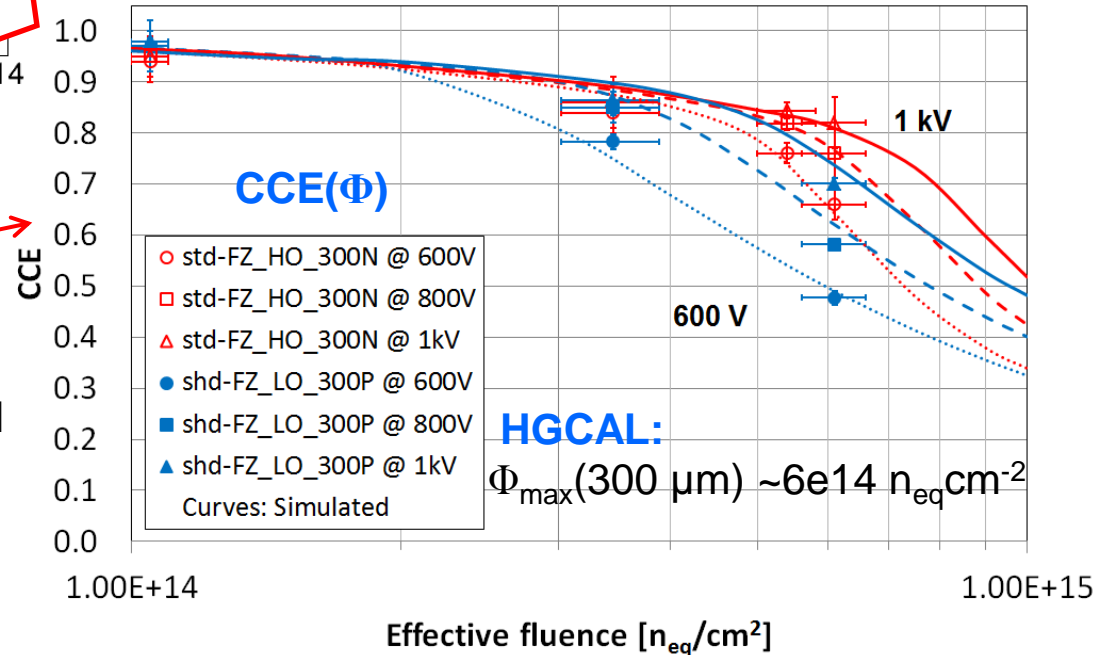


□ **HGCAL:** Highly segmented calorimeter @  $1.5 \leq \eta \leq 3.0 \rightarrow$  radiation dominated by neutrons

□ Neutron defect model,  $\Phi = 1e14 \sim 1e15 n_{eq}cm^{-2}$  [1] (proton & neutron models: backups 3 – 4):

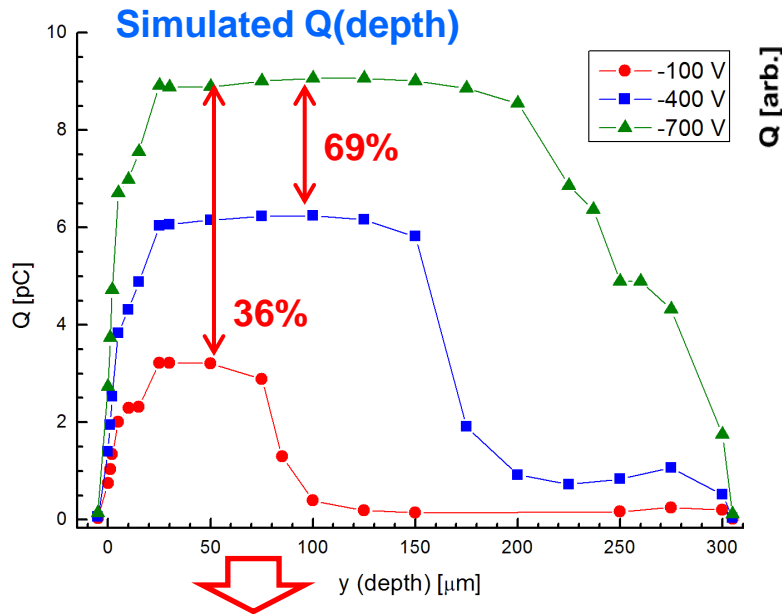
Type of defect	Level [eV]	$\sigma_e$ [cm <sup>2</sup> ]	$\sigma_h$ [cm <sup>2</sup> ]	C [cm <sup>-3</sup> ]
Acceptor	$E_C - 0.525$	$1.2e-14$	$1.2e-14$	$1.55*\Phi$
Donor	$E_V + 0.48$	$1.2e-14$	$1.2e-14$	$1.395*\Phi$

- **Measured:**  $\Phi = (6.1 \pm 0.5)e14 n_{eq}cm^{-2}$
- **TCAD simulated:**  $\Phi = 6.0e14 n_{eq}cm^{-2}$
- **CCE( $\Phi$ ) @  $(1 - \sim 6.5)e14 n_{eq}cm^{-2}$ :**  
Measured CCE closely reproduced by simulation
- TCAD input parameters from measured CV/IV & TCT pre-irradiation (devices: backups 5 – 6)

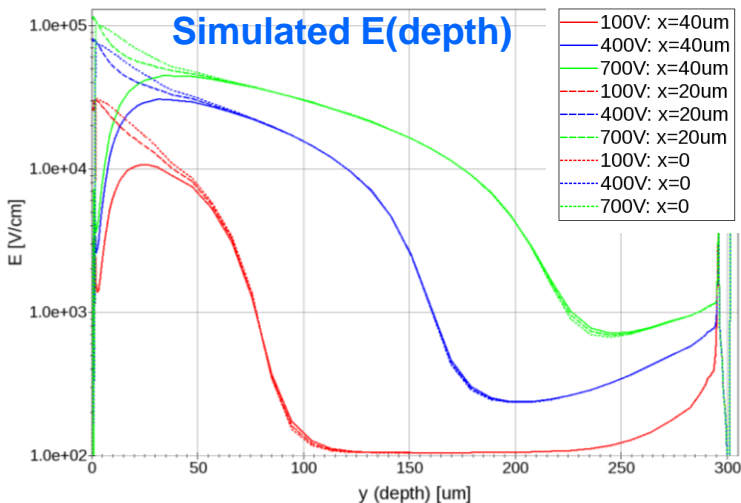
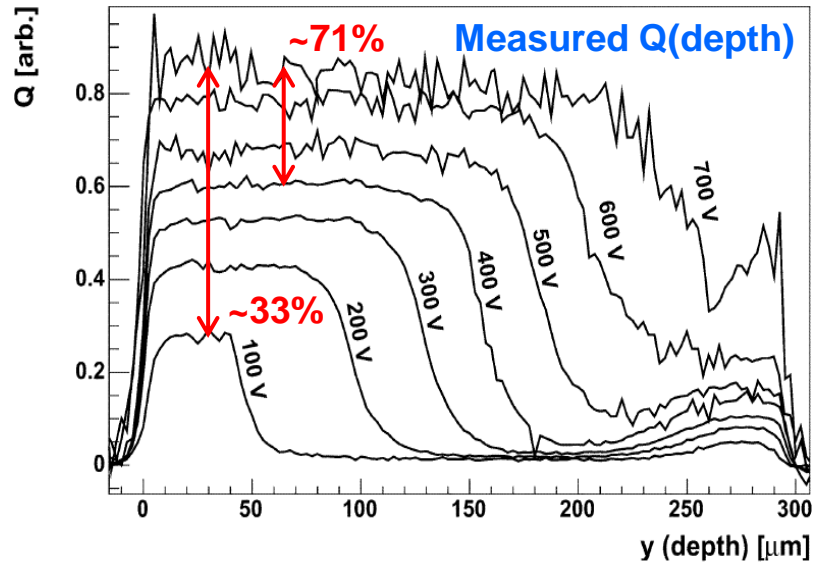


[1] R. Eber, PhD Thesis, KIT (2013)

# Edge-TCT: Neutron irradiated strip detector



[G. Kramberger et al. IEEE Trans. Nucl. Sci. 57 (2010) 2294]



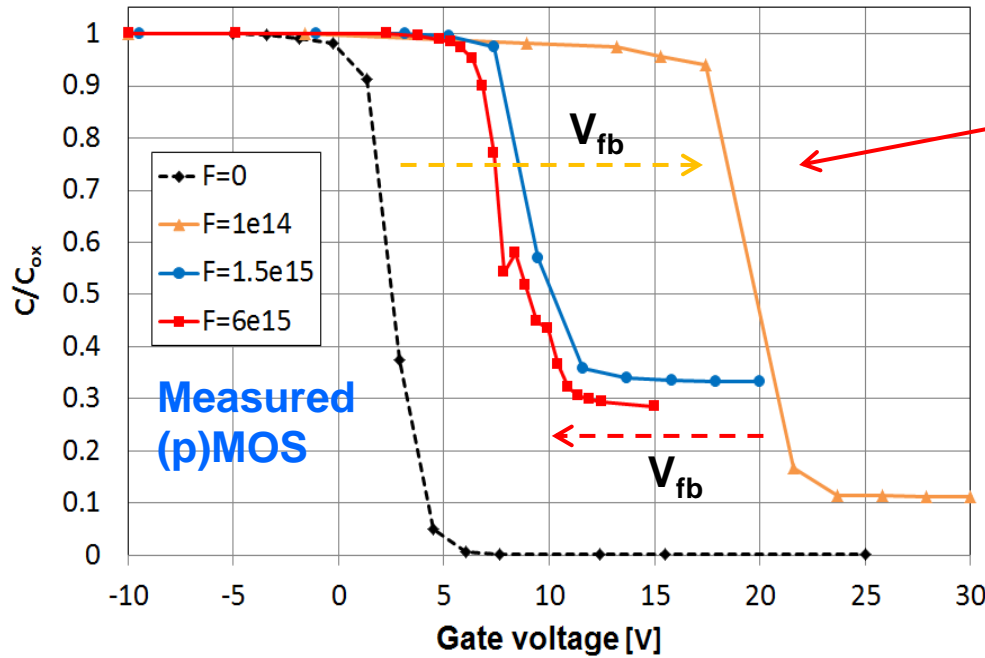
**x=0:**  
center of strip

**300  $\mu\text{m}$  n-on-p strip sensor:**  
 $\Phi=5e14 \text{ n}_{\text{eq}} \text{ cm}^{-2}$ ,  $N_f=1e11 \text{ cm}^{-2}$ , pitch=80  $\mu\text{m}$

- Experimental:** Estimate E-field from  $v_{\text{dr}}$  using edge-TCT
  - Amplitudes reproduced by simulation ([back-up 7](#))
  - Depletion depth accuracy increases w/ V  $\rightarrow$
- Simulation gives reliable estimation of E(depth) @ HV**

# Simulated defects II: surface damage

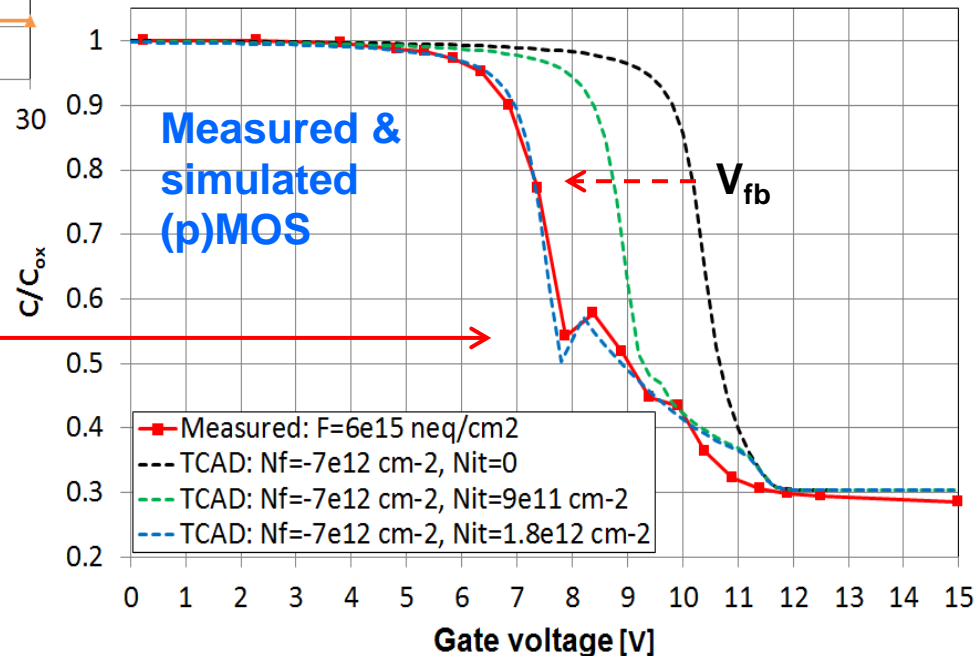
# Irradiated MOS: $N_f$ & interface traps ( $N_{it}$ )



- $\text{Al}_2\text{O}_3$  (alumina): Negative oxide charge ( $N_f$ )
- Neutron irradiation: Initial increase of MOS  $V_{fb}$ , then decrease → influence of donor  $N_{it}$ ?

## □ Interface trap test level:

Type of defect	Level [eV]	$\sigma_e$ [ $\text{cm}^2$ ]	$\sigma_h$ [ $\text{cm}^2$ ]	Density [ $\text{cm}^{-2}$ ]
Donor	$E_V + 0.6$	$1e-15$	$1e-15$	variable



- Decreased  $V_{fb}$ , slope change & dip @ depletion reproduced by simulation → evidence that  $N_{it,donor} \approx N_f$  @ high neutron  $\Phi$

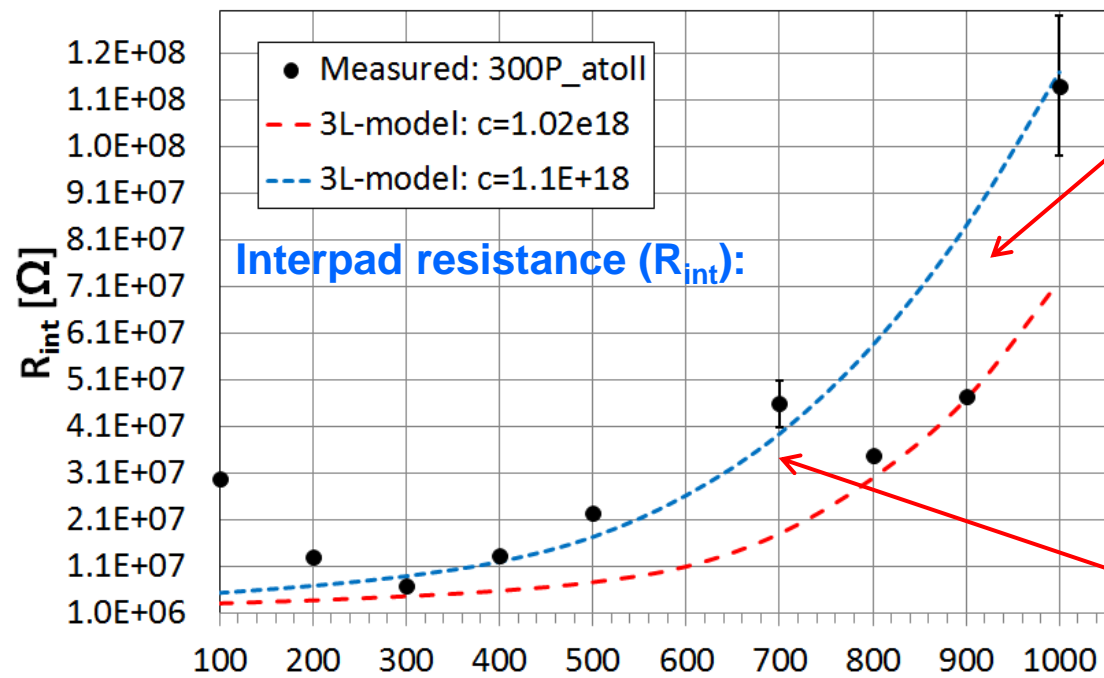
- $\text{SiO}_2$ : Positive  $N_f$

$$N_{f,eff} = \pm N_f + N_{it,donor}$$



# **Simulated defects III: bulk & surface damage**

# Measured/TCAD $R_{int}$ : 3L-model @ $1e15 n_{eq}/cm^2$



- Neutron irradiated pad sensor:  $\Phi_{eff} = 1.2e15 \pm 20\% n_{eq}/cm^2$ \*
- Measured: Pads isolated @ all V
- Neutron defect model [1]:  $\Phi = 1e15 n_{eq}/cm^2$ ,  $N_f = (1.41 \pm 0.15)e12 cm^{-2}$  → Pads isolated @  $V > 450 V$  (backup 9) → need more realistic surface model
- Preliminary 3L-model @  $\leq 2 \mu m$  depth &  $1e15 n_{eq}/cm^2$ ,  $N_f = 1.4e12 cm^{-2}$ : Pads isolated @ all V, stable  $C_{int}$  (backup 10)

\*) Measured  $R_{int}$  by R. Lipton & M. Alyari

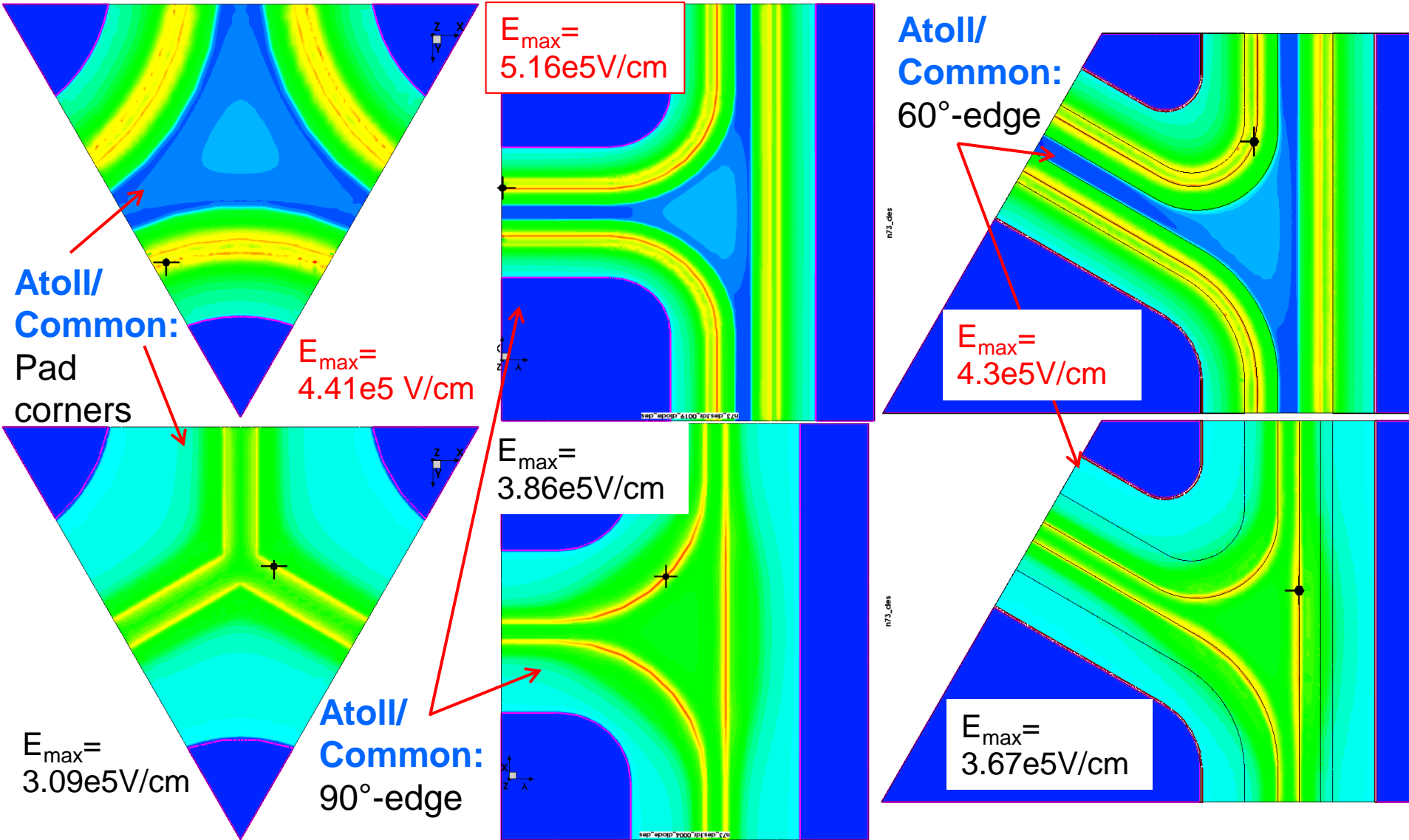
- Bulk properties of neutron model unaffected

Type of defect	Level [eV]	$\sigma_e$ [ $cm^2$ ]	$\sigma_h$ [ $cm^2$ ]	$C$ [ $cm^{-3}$ ]
Deep acc.	$E_C - 0.525$	$1.2e-14$	$1.2e-14$	$1.550^* \Phi$
Deep donor	$E_V + 0.48$	$1.2e-14$	$1.2e-14$	$1.395^* \Phi$
Shallow acc.	$E_C - 0.40$	$8e-15$	$2e-14$	<b><math>1.1e18</math></b>

[1]

- 2D-devices: backup 8
- 3L-model for protons: backups 11 – 12

# 3D-HGCAL regions & p-stops: $E_{\max}$ @ 1 kV



# Outlook: Sensors at extreme fluences



## □ Si sensors @ extreme fluences ( $\Phi \geq 1e16 \text{ n}_{eq} \text{ cm}^{-2}$ ):

- **Low-T operation:** Mitigate leakage current
- **Cryo-T operation:** Mobility & trapping times increase  $\rightarrow$  faster output signals & higher  $Q_{coll}$
- **Electron collection:**  $\sim 3$  times higher mobility & longer trapping times to holes
- **Oxygenated bulk:** Suppressed build-up of negative space charge (charged hadrons)
- **Short drift distance (<100  $\mu\text{m}$ ):** Minimize trapping probability
- **Large signal & short drift distance:**
  - **LGAD:** Charge-multiplication layer (p-well)
  - **3D-pixels:** Decoupled signal amplitude & drift distance

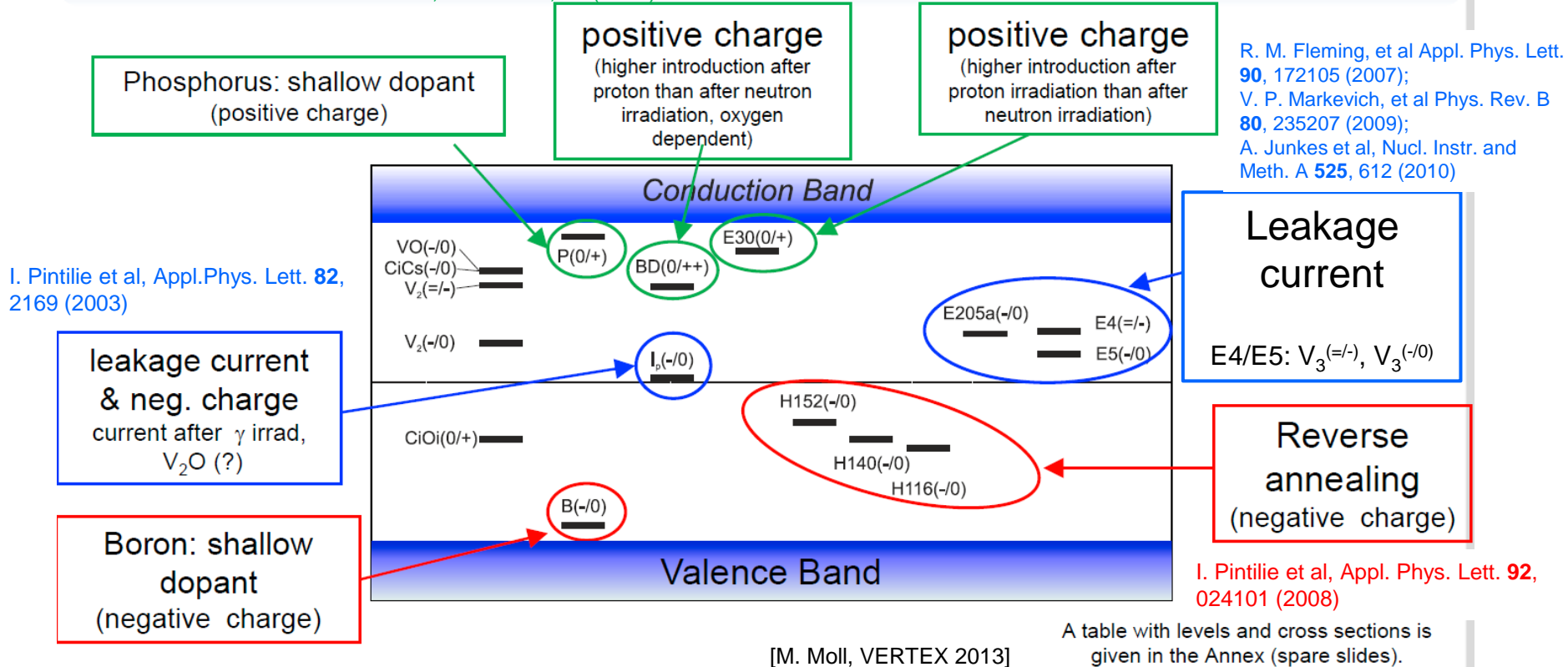
## □ Extreme- $\Phi$ defect model:

- Start by tuning against measured CCE &  $N_{eff}$  evolution @  $\Phi > 1e15 \text{ n}_{eq} \text{ cm}^{-2}$  (level depths, trap concentrations,..)
- Add E-field tuning (edge-TCT) & surface properties ( $R_{int}$ ,  $C_{int}$ , charge sharing,...)

# Back-up 1: Defect Characterization Overview



Pintilie et al, NIM A **514**, 18 (2003) & NIM A **556**, (1), 197 (2006);  
E. Fretwurst et al, NIM A **583**, 58 (2007)



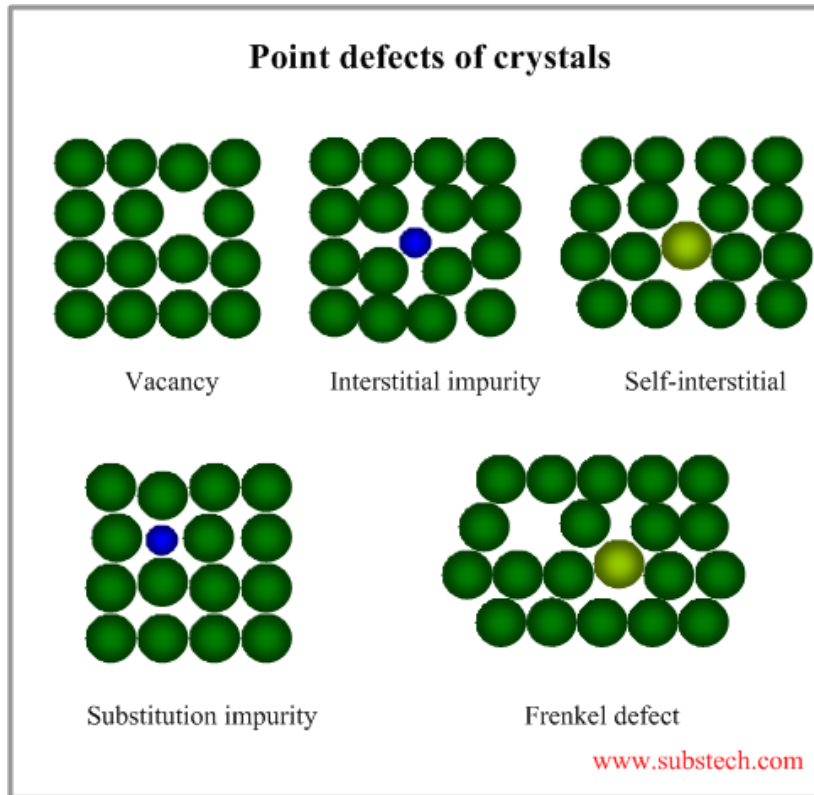
- Trapping:** Indications that E205a and H152K (midgap levels) are important
- Consistent set of defects observed after p,  $\pi$ , n,  $\gamma$  and e irradiation
- Understanding of defect properties/macroscopic effects is essential for the implementation of defect simulation**

# Back-up 2: Defects in silicon: Overlook



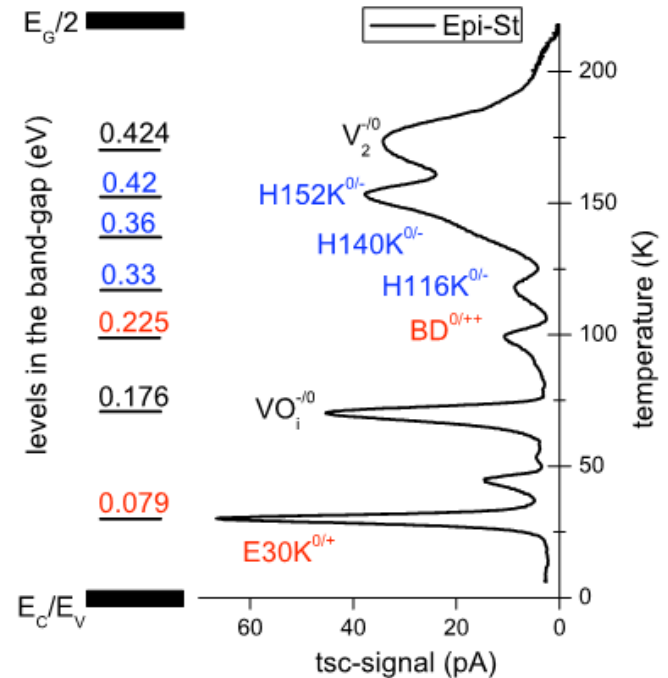
- Each defect: Energy level in Si bandgap or variety, depending on conglomeration of defects
- Multitude of E-levels, cross sections & concentrations: **huge parameter space to model**

- 11 defect levels proved to influence performance of irradiated Si detectors → **Effective model is needed for simulation**



[R. Eber, 8<sup>th</sup> Detector Workshop, Berlin, 2015]

## Energy levels from Thermally Stimulated Current (TSC) measurement



**H defects:** [I. Pintilie et al., Appl. Phys. Lett. **92**, 024101 (2008)]  
**BD:** [I. Pintilie et al., NIM A **514**, 18 (2003)] & [I. Pintilie et al., NIM A **556**, (1), 197 (2006)] & [E. Fretwurst et al., NIM A **583**, 58 (2007)]  
**E30:** [I. Pintilie et al., NIM A **611**, 52-68 (2009)]

# Back-up 3: Defect simulations - TCAD



## □ Motivation for Technology Computer-Aided Design (TCAD) simulations:

- E-fields not possible to measure directly → Predict E-fields & trapping in irradiated sensors
- Verify measurements → Find physics behind unexpected results
- Predictions for novel structures & conditions → Device structure optimization

### □ Principle for irradiated Si detector TCAD simulation:

#### ▪ Minimized set:

- 2 midgap levels DD & DA applied to reproduce & predict:  
Bulk generated current + E(depth) + trapping
- **Surface damage:** Fixed charge density  $N_f$  @ SiO<sub>2</sub>/Si interface w/ interface traps  $N_{it}$  of varying depth distributions

## □ Sentaurus TCAD proton & neutron defect models for $\Phi_{eq} = 1e14 \sim 1e15 \text{ cm}^{-2}$ @ T=253 K [1]

Defect type	Level [eV]	$\sigma_e$ [cm <sup>2</sup> ]	$\sigma_h$ [cm <sup>2</sup> ]	Concentration [cm <sup>-3</sup> ]
Deep acc.	$E_C - 0.525$	1e-14	1e-14	$1.189 * \Phi + 6.454e13$
Deep donor	$E_V + 0.48$	1e-14	1e-14	$5.598 * \Phi - 3.959e14$

Defect type	Level [eV]	$\sigma_e$ [cm <sup>2</sup> ]	$\sigma_h$ [cm <sup>2</sup> ]	Concentration [cm <sup>-3</sup> ]
Deep acc.	$E_C - 0.525$	1.2e-14	1.2e-14	$1.55 * \Phi$
Deep donor	$E_V + 0.48$	1.2e-14	1.2e-14	$1.395 * \Phi$

## □ Can trapping be explained in frame of 2-DL model? [2]

- $\beta \approx 5e-7 \text{ s}^{-1}\text{cm}^2$  &  $\Phi = 1e14 \text{ cm}^{-2}$  →  $\tau = 20 \text{ ns}$
- Trapping X-section  $\sigma = 1e-14 \text{ cm}^2$ ,  $v_{th} = 2e7 \text{ cm/s}$

→  $N_t = 1/[\sigma v_{th} \tau] = 2.5e14 \text{ cm}^{-3}$  or intro rate  $\eta(N_t) = 2.5$

$\eta(N_t)$ ,  $\eta(\text{DA})$  &  $\eta(\text{DD})$  have equal range →  
**2-DL model has potential to model CCE( $\Phi$ )**

[2] V. Eremin, RD50 SWG meeting, March 2013

# Back-up 4: DP & LC for neutron & proton defect models



300  $\mu\text{m}$  thick p-on-n pad detector @  $T=253\text{ K}$

Fluences :

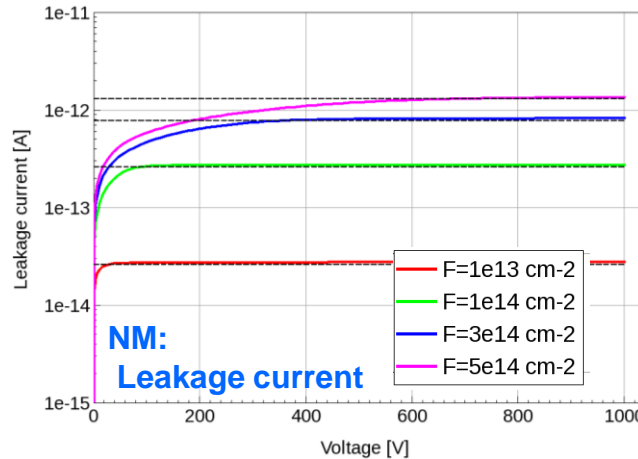
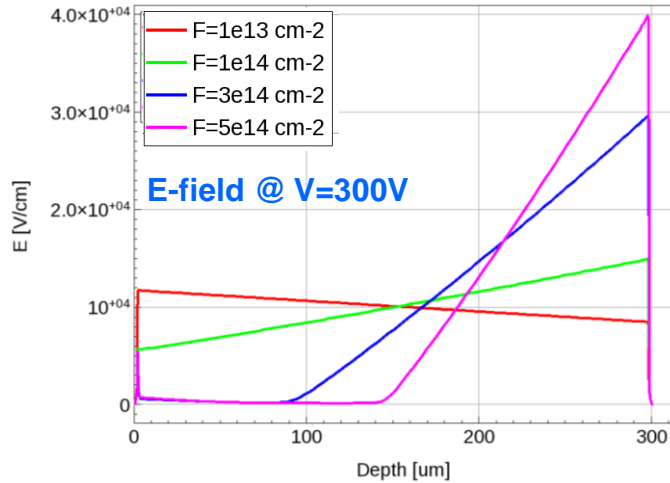
$$\Phi = 1\text{e}13 - 5\text{e}14\text{ n}_{\text{eq}}\text{ cm}^{-2}$$

DP is produced by both models (more pronounced in PM due to higher trap concentration for given  $\Phi$ )

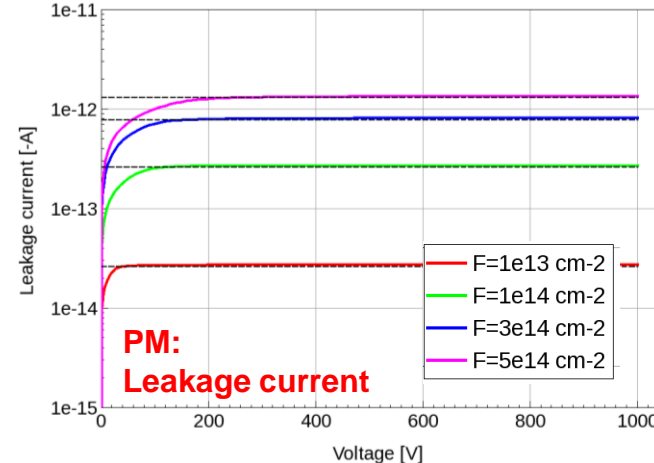
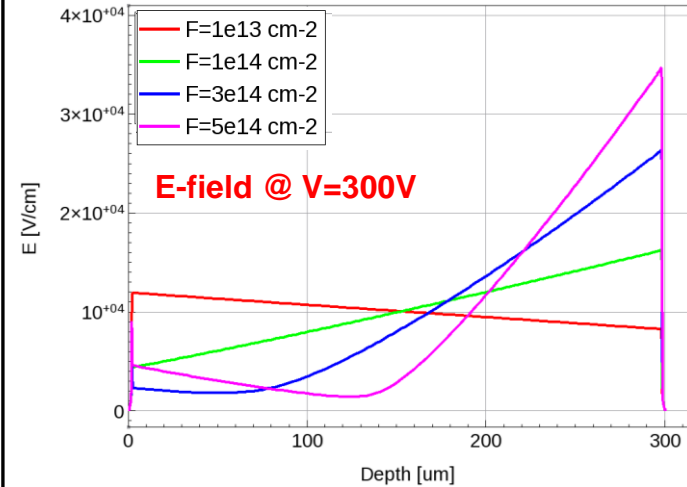
Dashed black lines: experimental LC by  $\Delta I = \text{Volume} \cdot \alpha \cdot \Phi$ ,  $\alpha(253\text{K}) \approx 8.9 \cdot 10^{-19}\text{ A} \cdot \text{cm}^{-1}$

LC has perfect match with experimental values

NEUTRON MODEL (NM)



PROTON MODEL (PM)

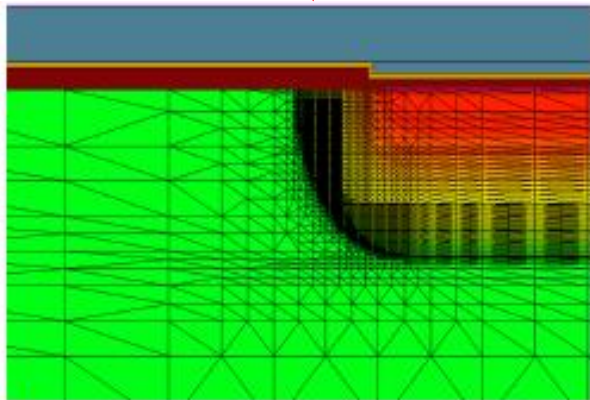
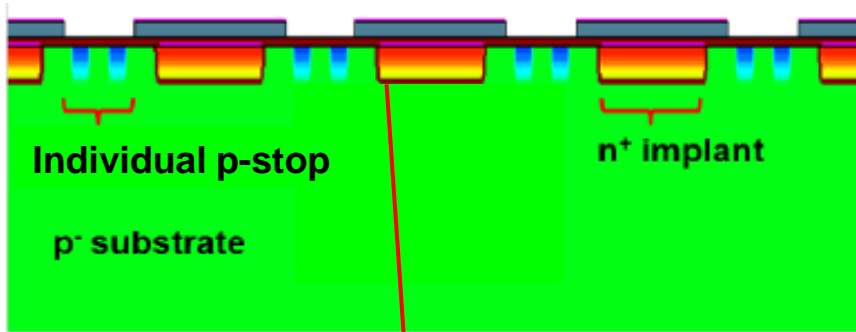




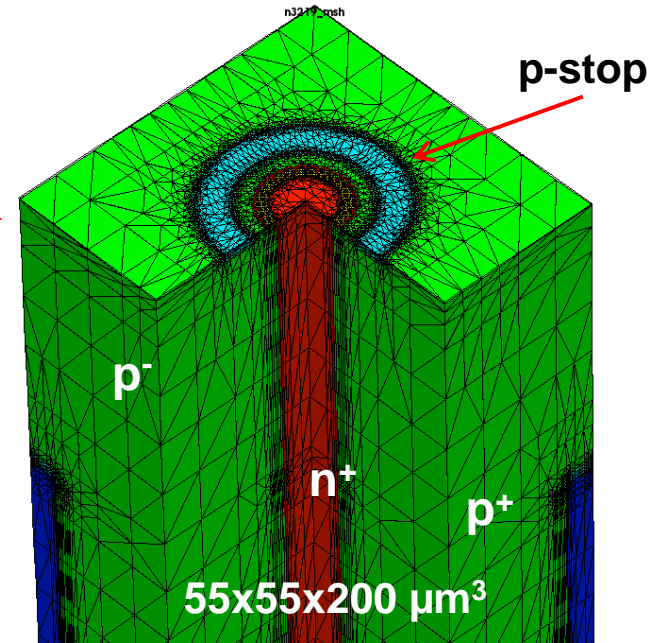
# Backup 5: Simulated sensors - 2D & 3D designs



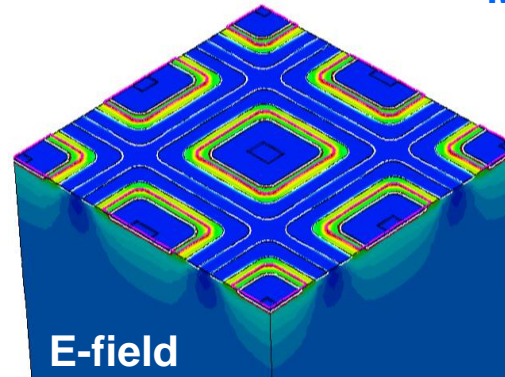
- **Pad & strip sensors:** Constant E-field in 3<sup>rd</sup> dimension → 2D structures sufficient for accurate results → extend to real device dimensions by area factor
- **Planar & 3D-columnar pixel sensors:** 3D-design required for correct modeling of E-fields



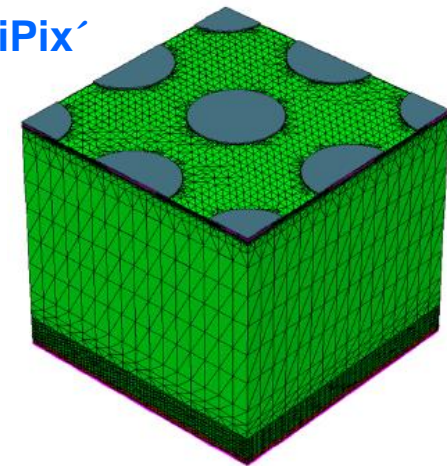
50x50 pixel sensor



'MediPix'

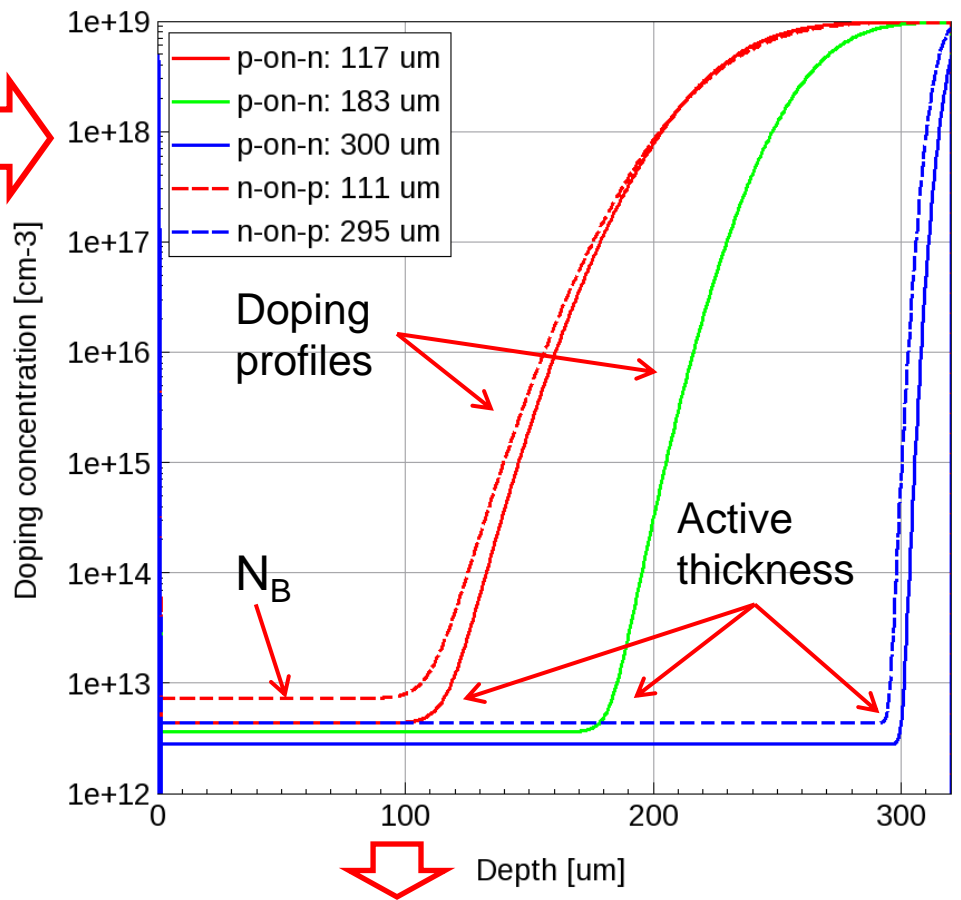
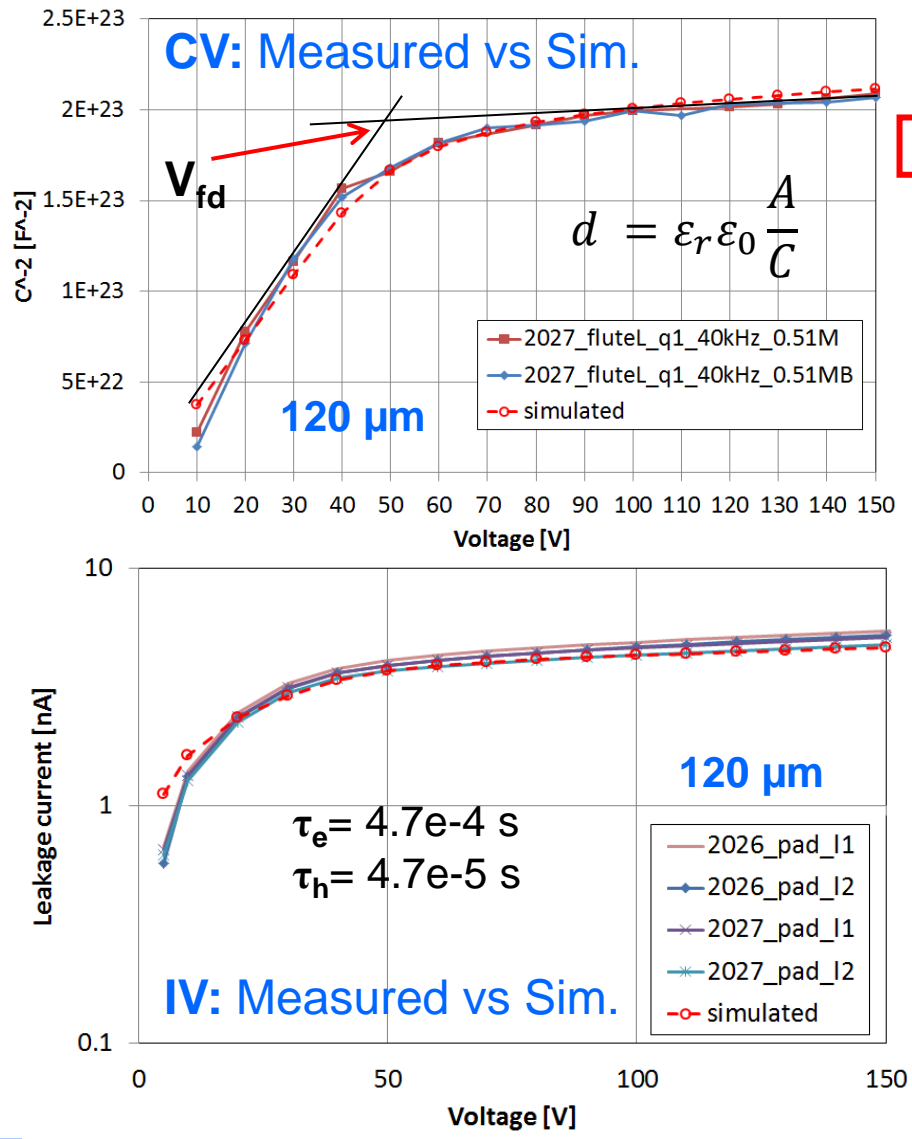


E-field





# Backup 6: Measured CV/IV - Simulation input



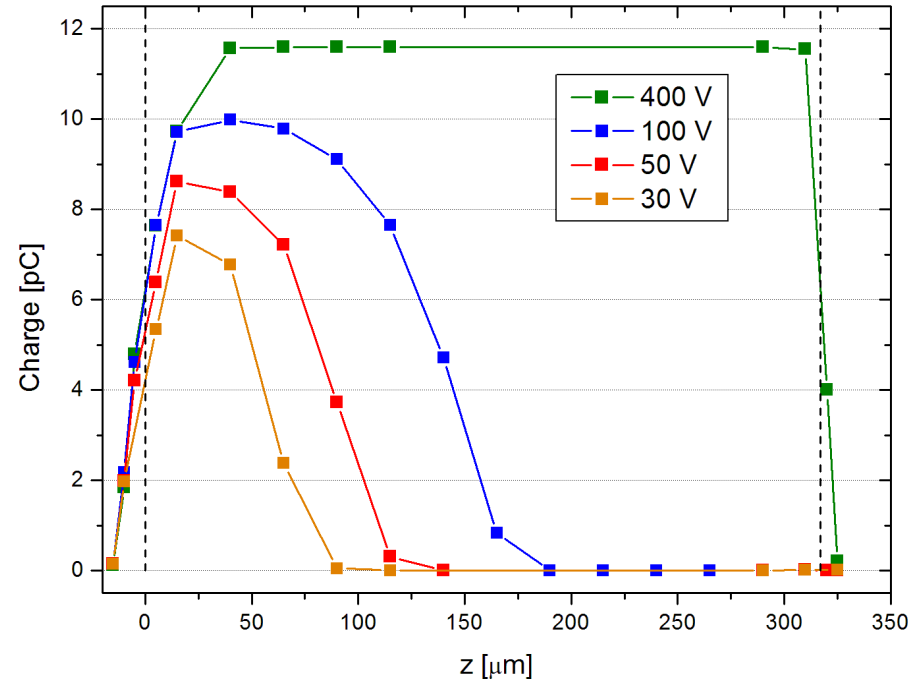
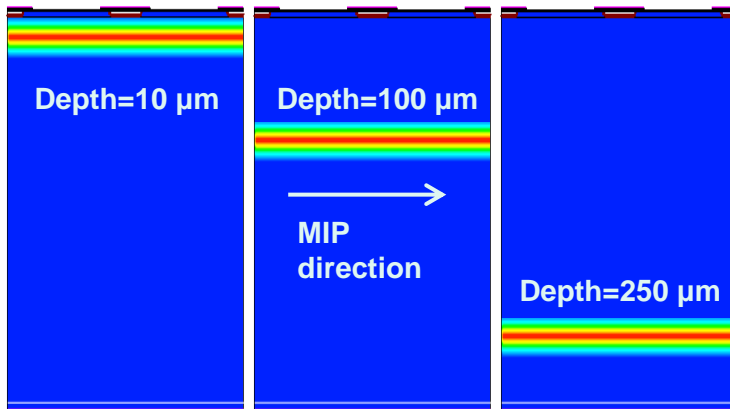
Extracted parameters to tune simulation to measured LC by carrier trapping times

# Back-up 7: Method for simulated edge-TCT



- **Experimental:** Estimate E-field from drift velocity  $v_{\text{drift}}$  using eTCT → provides measurement of collection time  $t_c \propto v_{\text{drift}}$

## Principal of edge-TCT simulation:

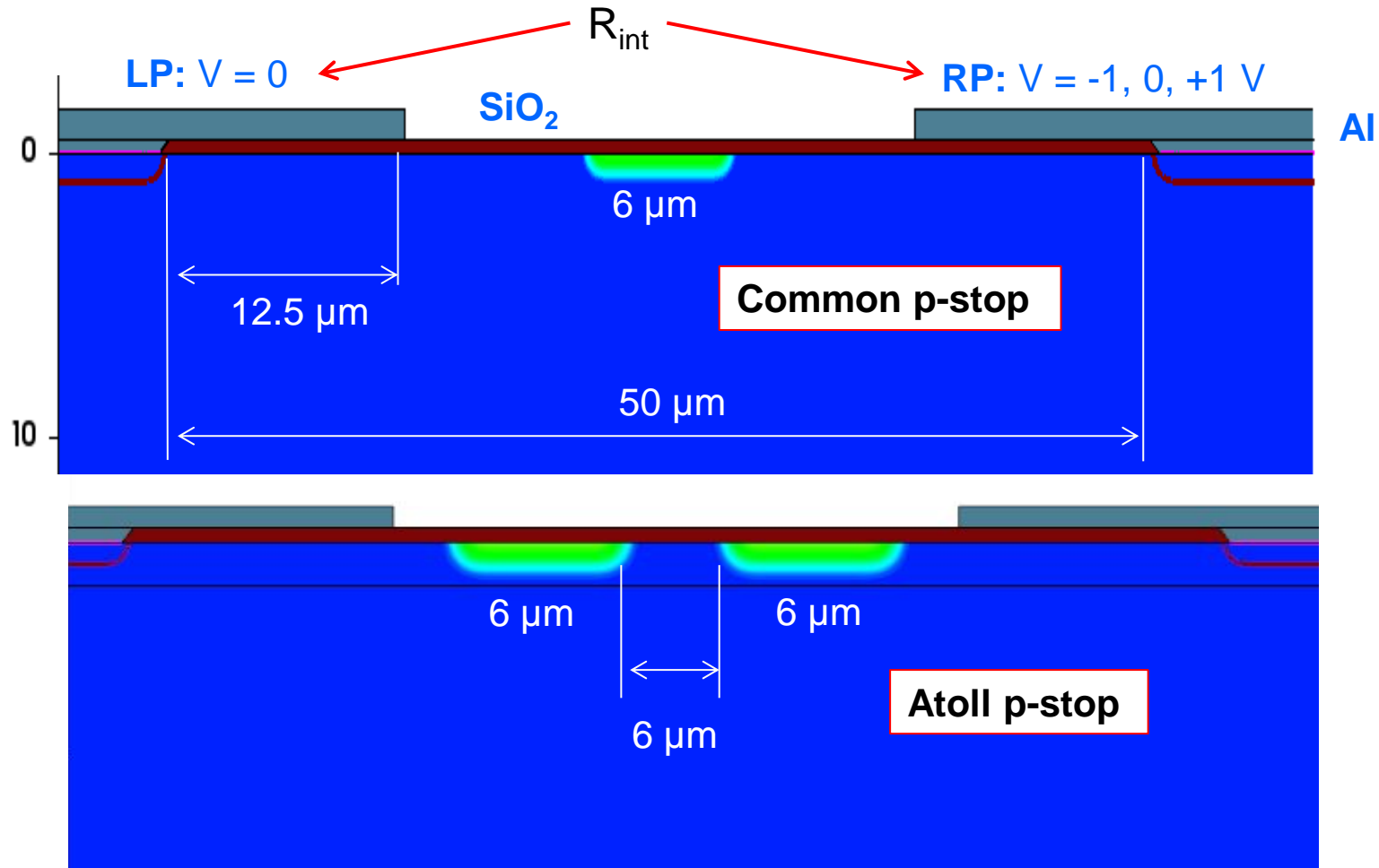


- TCAD simulated edge-TCT collected charges  $Q(z)$  for non-irradiated 320  $\mu\text{m}$  p-on-n strip detector @  $V < V_{\text{fd}}$  &  $V > V_{\text{fd}}$ ,  $T = 293 \text{ K}$
- **Dashed vertical lines:** Active region of detector (defined from center of rising & descending slopes of  $Q(z)$  distribution) → Different E-field extensions into bulk from pn-junction at  $z=0$  are reflected by  $Q(z)$
- **Differences in  $Q(z)$  amplitude:** Reproduced by using laterally extended device structure → extension of E-field to detector edges

# Backup 8: 8-in sensors - Common/atoll p-stops



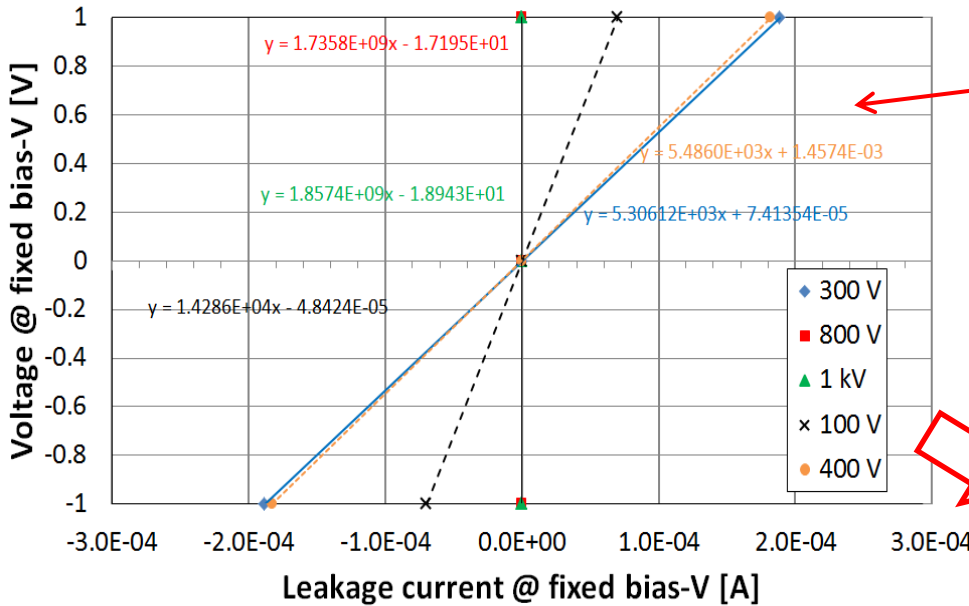
□ TCAD structures: DC-coupled 200P



➡ **Open p-stop parameters:** Peak doping ( $N_{\text{ps}}$ ) & depth ( $d_{\text{ps}}$ )



# Backup 9: TCAD $R_{int}$ - 3 extraction methods



**M1:**  $R_{int}$  = slope of  $V(RP)$  vs  $I(RP)$  for fixed bias  $V$  (laborious)  $\rightarrow$  same as FNAL measured  $R_{int}^*$

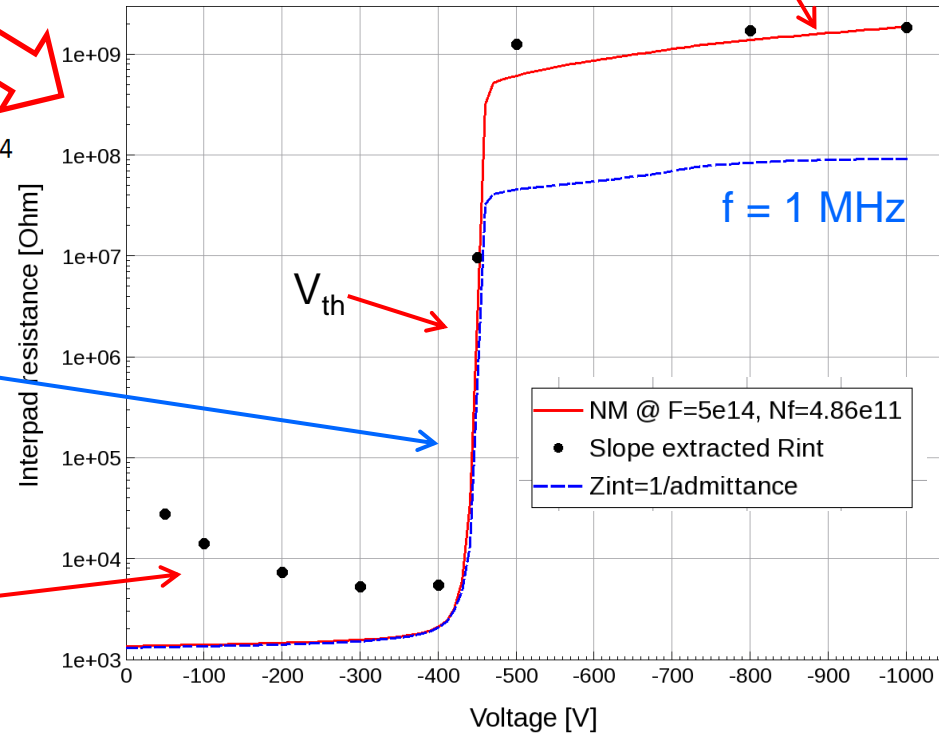
**M2:**  $V(\text{on/off}) @ RP: R_{int} = \frac{U(1V)}{I(1V) - I(0V)}$

$\rightarrow$  given directly by simulation (fast)

**M3:**  $R_{int} \approx Z_{int} = 1/\text{admittance} \rightarrow$  given directly by simulation (fast)

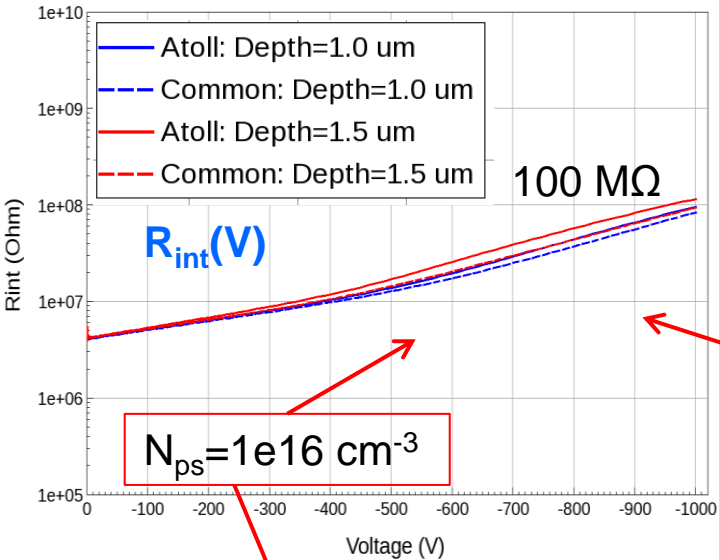
**3 methods:** Different features, same  $V(\text{threshold}) (V_{th})$

- Method 1: Anomalous increase of  $R_{int}$  @ LV (not expected)

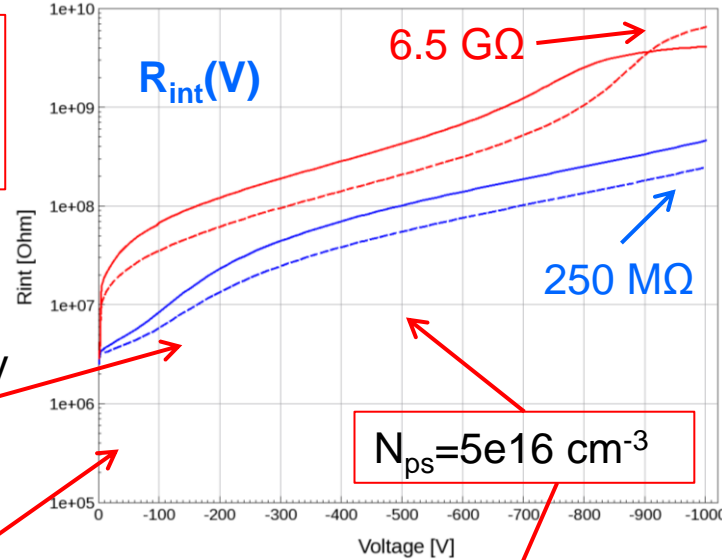


\*) Measured  $R_{int}$  by R. Lipton & M. Alyari

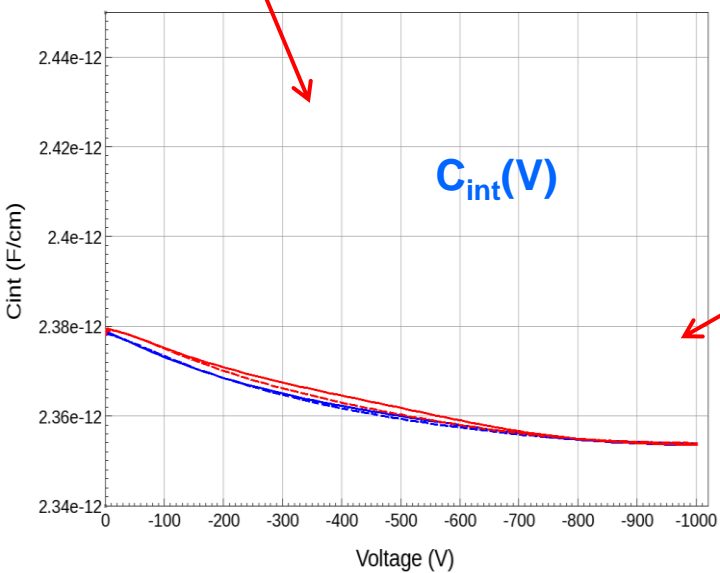
# Backup 10: Common vs atoll p-stop - $R_{int}/C_{int}$



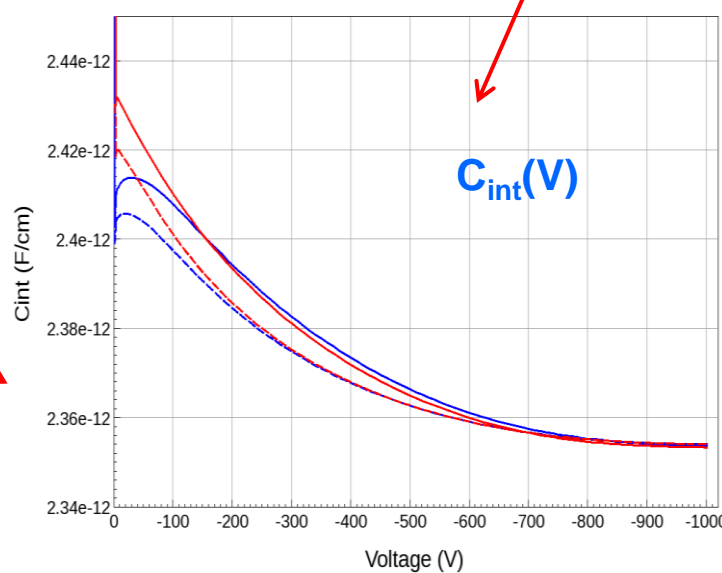
$\Phi_{eff}=1e15 \text{ n}_{eq}/\text{cm}^2$ ,  
 $N_f=1.4e12 \text{ cm}^{-2}$ ,  
 3L-defect model



- Common & atoll:** Pads isolated @ all V
- Atoll 1  $\mu\text{m}$ :** ~1.8-fold higher  $R_{int}$  @ HV
- Common 1.5  $\mu\text{m}$ :** ~1.6-fold higher  $R_{int}$  @ 1 kV



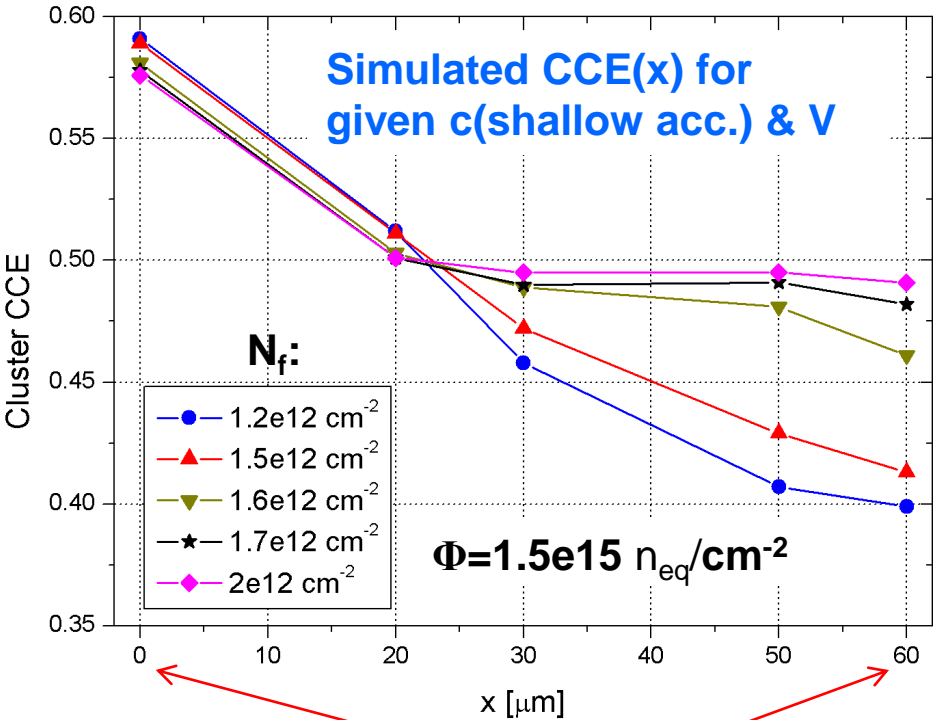
- Common & atoll:**
  - $\Delta C_{int} \approx 0.03 \text{ pF/cm}$
  - $\Delta C_{int} \approx 0.08 \text{ pF/cm}$





# Back-up 11: Proton bulk & surface damage: CCE(x)

Heavily irradiated strip detectors demonstrate significant position dependency of CCE [CCE(x)]



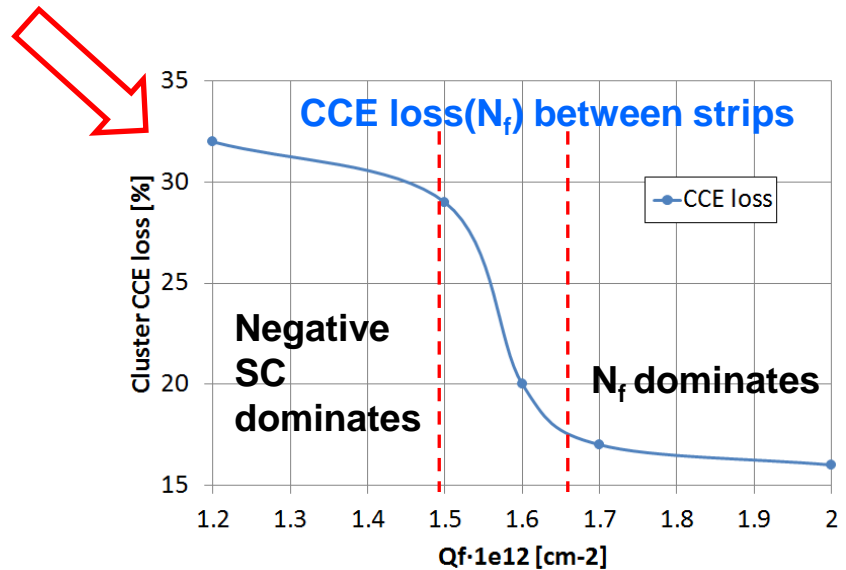
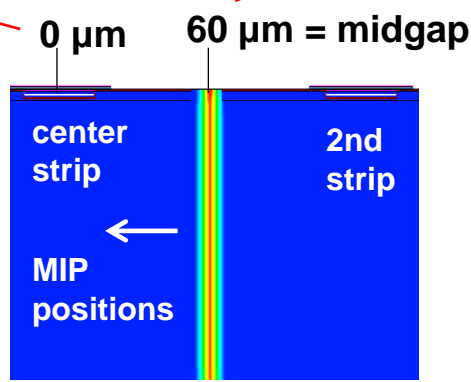
**CCE loss**

- 16%
- 17%
- 20%
- 29%
- 32%

**Non-uniform 3-level model:**  
 $N_{it}$  cannot be used: measured  $C_{int}$  not reproduced → need deeper distribution → 3-level model within 2 μm of device surface + proton model in bulk:  
 ○  $R_{int}$  &  $C_{int}$  in line w/ measured also @ high  $\Phi$  &  $N_f$  (back-up 13)

**Strips isolated:**  
 Cluster CCE decreases towards midgap

**Strips shorted:**  
 Cluster CCE independent of position

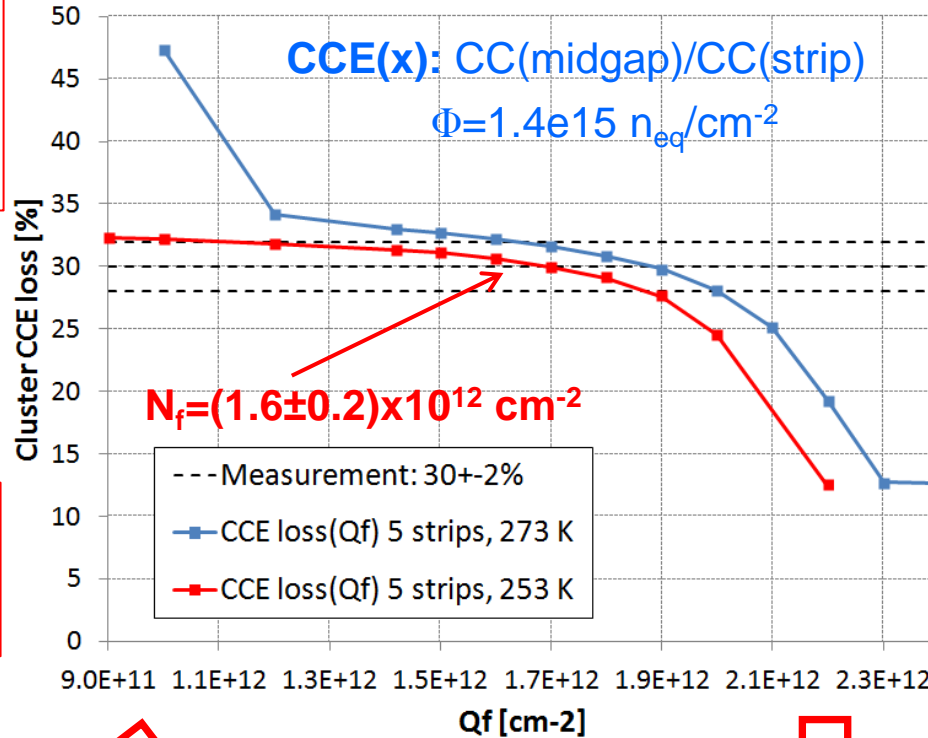


[T. Peltola, JINST 9 (2014) C12010 & T. Peltola et al., JINST 10 (2015) C04025]



# Back-up 12: Proton 3L-model

Heavily irradiated strip detectors demonstrate significant position dependency of CCE [CCE(x)]



**Test beam measured:**

- Strips isolated
- CCE loss ~30%

3-level model within 2 μm of device surface + proton model in bulk:  
 $R_{int}$  &  $C_{int}$  in line w/ measured also @ high  $\Phi$  &  $N_f$



**Preliminary parametrization for  $\Phi = 3e14 - 1.4e15 \text{ n}_{eq}/\text{cm}^2$**

Defect type	Level [eV]	$\sigma_e$ [cm <sup>2</sup> ]	$\sigma_h$ [cm <sup>2</sup> ]	C [cm <sup>-3</sup> ]
Deep acc.	$E_C - 0.525$	1e-14	1e-14	$1.189 \cdot \Phi + 6.454e13$
Deep donor	$E_V + 0.48$	1e-14	1e-14	$5.598 \cdot \Phi - 3.959e14$
Shallow acc.	$E_C - 0.40$	8e-15	2e-14	$14.417 \cdot \Phi + 3.168e16$

Irradiation produces shallow traps close to surface → greater drift distance, higher trapping of carriers